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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/772,511	02/05/2004	Jia-Xing Lin	250914-1020	5673	
24504 THOMAS, KA	7590 12/14/2007 AYDEN, HORSTEMEY	EXAMINER			
600 GALLERIA PARKWAY, S.E.			PATEL, REEMA		
STE 1500 ATLANTA, G	A 30339-5994	ART UNIT	PAPER NUMBER		
, 0			2812		
			MAIL DATE	DELIVERY MODE	
			12/14/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		Applicati	on No.	Applicant(s)				
Office Action Summary		10/772,5	11	LIN ET AL.				
		Examine	•	Art Unit				
		Reema Pa	atel	2812	•			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHO WHIC - Exter after - If NO - Failui Any r	ORTENED STATUTORY PERIOD FOR FOR HEVER IS LONGER, FROM THE MAILIN Issions of time may be available under the provisions of 37 CSIX (6) MONTHS from the mailing date of this communicating period for reply is specified above, the maximum statutory re to reply within the set or extended period for reply will, by eply received by the Office later than three months after the digital patent term adjustment. See 37 CFR 1.704(b).	NG DATE OF THE CFR 1.136(a). In no eviction. period will apply and we statute, cause the app	HIS COMMUNICATIO ent, however, may a reply be ti ill expire SIX (6) MONTHS fron dication to become ABANDON	N. imely filed in the mailing date of this co ED (35 U.S.C. § 133).				
Status								
2a)☐	Responsive to communication(s) filed on This action is FINAL . 2b) Since this application is in condition for al closed in accordance with the practice un	This action is religional This action is religious. The light section is the light section in the light section is religious.	non-final. for formal matters, pr		e merits is			
Dispositi	on of Claims							
5)⊠ 6)⊠ 7)⊠ 8)□ Applicati 9)□ 10)⊠	Claim(s) 1-20 is/are pending in the application (a) Of the above claim(s) is/are with Claim(s) 13-20 is/are allowed. Claim(s) 1-5 and 9-12 is/are rejected. Claim(s) 6-9 is/are objected to. Claim(s) are subject to restriction and con Papers The specification is objected to by the Example drawing(s) filed on is/are: a) Applicant may not request that any objection to Replacement drawing sheet(s) including the of the oath or declaration is objected to by the example of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to by the control of the oath or declaration is objected to be the oath of the oath oath of the oath oath oath oath oath oath oath oath	and/or election raminer. accepted or b) to the drawing(s) to correction is required.	equirement. objected to by the be held in abeyance. Sered if the drawing(s) is older.	ee 37 CFR 1.85(a). bjected to. See 37 Cl				
Priority u	nder 35 U.S.C. § 119	•						
12) △ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) △ All b) ☐ Some * c) ☐ None of: 1. △ Certified copies of the priority documents have been received. 2. ☐ Certified copies of the priority documents have been received in Application No 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.								
2) D Notic 3) D Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-94 nation Disclosure Statement(s) (PTO/SB/08) No(s)/Mail Date	48)	4) Interview Summar Paper No(s)/Mail D 5) Notice of Informat 6) Other:	Date				

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DETAILED ACTION

Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 3. Claims 1, 4-5, and 12 are rejected under 35 U.S.C. 102(b) as being anticipated by Nakajima et al. (U.S. 2001/0010391 A1).
- 4. Regarding claim 1, Nakajima et al. discloses forming a heat sink layer on a substrate and patterning the heat sink layer to form an opening, wherein the opening exposes a portion of the substrate ([0052]); forming an amorphous silicon layer on the substrate ([0053]); dehydrogenating the amorphous silicon layer ([0053]); and laser annealing the amorphous silicon layer to form a polysilicon layer ([0054]).
- 5. Regarding claims 4-5, Nakajima et al. discloses the laser annealing comprises using a XeCl excimer laser light source at an energy of 100-500 mJ/cm² ([]0054).

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6. Regarding claim 12, Nakajima et al. discloses that the subsequently formed polysilicon layer is used in a TFT device and discloses further processing steps ([0052]-[0074]).

Claim Rejections - 35 USC § 103

- 7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 8. Claims 1-3 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsao (U.S. 6,867,074 B2) in view of Nakajima et al. (U.S. 2001/0010391 A1).
- 9. Regarding claim 1, Tsao discloses forming a heat sink layer on a substrate and patterning the heat sink layer to form an opening, wherein the opening exposes a portion of the substrate (col 4, line 67 col 5, line 2); forming an amorphous silicon layer on the substrate (col 5, lines 16-17); and laser annealing the amorphous silicon layer to form a polysilicon layer (col 5, lines 20-23).
- 10. Yet, Tsao does not disclose dehydrogenating the amorphous silicon layer before laser annealing. However, Nakajima et al. discloses dehydrogenating an amorphous silicon surface ([0053]) so as to prevent a hydrogen explosion during the subsequent laser annealing. Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify Tsao with dehydrogenating the amorphous silicon surface, as taught by Nakajima et al., so as to prevent a hydrogen explosion during the subsequent laser annealing.

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11. Regarding claims 2-3, Tsao discloses the heat sink layer comprises a silicon

nitride layer deposited by a PECVD process (col 4, line 67 – col 5, line 3).

12. Claims 9-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over

Nakajima et al. (U.S. 2001/0010391 A1) as applied to claim 1 above, and further in view

of Lin (U.S. 7,071,083 B2).

13. Regarding claims 9-11, Nakajima et al. does not disclose forming a heating layer

on the amorphous silicon layer. However, Lin discloses forming a semitransparent

heating layer on the amorphous silicon (col 3, lines 32-53) which has the advantage of

increasing the grain size of the subsequently formed polysilicon layer. Therefore, it

would have been obvious to one having ordinary skill in the art at the time the invention

was made to form a heating layer on the amorphous silicon prior to annealing so as to

increase the grain size of the subsequently formed polysilicon film.

Allowable Subject Matter

14. Claims 6-8 are objected to as being dependent upon a rejected base claim, but

would be allowable if rewritten in independent form including all of the limitations of the

base claim and any intervening claims. Claim 6 contains allowable subject matter

because of the limitation of forming a heat resistant layer before forming the heat sink

layer and during the step of patterning the heat sink layer, exposing the heat resistant

layer. Claims 7-8 depend on claim 6.

15. Claims 13-20 are allowed. Claim 13 is allowable because of the limitation of

forming a heat resistant layer before forming the heat sink layer and during the step of

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patterning the heat sink layer, exposing the heat resistant layer. Claims 14-20 depend

on claim 13.

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Reema Patel whose telephone number is 571-270-

1436. The examiner can normally be reached on M-F, 8:00-4:30 EST.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone

number for the organization where this application or proceeding is assigned is 571-

273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

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USPTO Customer Service Representative or access to the automated information

system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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SUPERVICORY....

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